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High voltage hybrid organic photovoltaics using a zinc oxide acceptor and a subphthalocyanine donor†

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We demonstrate hybrid organic photovoltaic (HOPV) bilayer devices with very high open circuit voltages (V_{OC}) of 1.18 V based on a sol–gel processed zinc oxide (ZnO) acceptor and a vacuum deposited boron subphthalocyanine chloride (SubPc) donor layer. X-ray photoelectron spectroscopy (XPS) and Kelvin Probe (KP) measurements of the ZnO/SubPc interface show that the ZnO preparation conditions have a significant impact on the film composition and the electronic properties of the interface, in particular the work function and interface gap energy. Low temperature processing at 120 °C resulted in a ZnO work function of 3.20 eV and the highest V_{OC} of 1.18 V, a consequence of the increased interface gap energy.

1. Introduction

The field of organic photovoltaics (OPVs) has attracted considerable attention due to its potential for low cost solar energy conversion and its compatibility with non-rigid substrates. Organic materials allow many fabrication techniques to be employed that are simply not available for inorganic PVs,¹ including the use of printable semiconductors and electrodes,² spray coating,³ and spin coating,⁴ as well as the viability of large-scale, low cost production methods such as roll-to-roll processing.⁵ Improvements in the performance of OPVs have been achieved through the development of new absorbing materials, the use of interfacial layers, novel multi-stack architectures and through the effective use of dopants.⁶

The related research field of hybrid organic photovoltaics (HOPVs) has also attracted considerable recent attention. HOPVs typically combine the use of a p-type organic donor with an n-type inorganic acceptor such as a transition metal oxide (TMO). Zinc oxide (ZnO) has been the most commonly studied acceptor material and can be processed using a number of methods including electrodeposition,⁷ pulsed laser deposition,⁸ spray pyrolysis,^{9,10} and the sol–gel process.¹¹ It has many appealing properties including high electron mobility,¹² high transparency and the relative ease of fine tuning its morphological properties.¹³ To date, ZnO has been used in

HOPV devices primarily as an electron-extracting layer providing ohmic contact with commonly used fullerene-based acceptors and thereby improving charge collection,^{14,15} however it has also been used as a direct replacement of the fullerene acceptor.¹⁶

The tunability of the ZnO conduction band (CB) also makes it an attractive material for HOPV applications, in particular as a means of enhancing the interface gap energy (I_g) when combined with different organic donors; I_g being the difference between the highest occupied molecular orbital (HOMO) of the donor and the lowest unoccupied molecular orbital (LUMO) of the acceptor. The I_g is known to be significant in the field of OPVs as the maximum achievable open circuit voltage (V_{OC}) of the cell can be predicted from the I_g minus any losses specific to each device due to thermodynamic and dissociation losses, band bending, energy losses at the contacts and recombination.^{17–20} For the most commonly used organic acceptor material, C_{60} , one of the limitations is the poor V_{OC} that is achieved with a significant number of organic donor materials due to the deep lying LUMO level (~ 4.5 eV), and therefore the associated losses as a result of an excessively large energy offset (Δ_{LUMO}).^{21,22} Therefore, despite C_{60} functioning as an efficient acceptor material, there is the opportunity of improving the V_{OC} further by exploiting other material combinations that increase I_g .

The simplest HOPV architecture is a planar bilayer structure with a single absorbing organic donor. If in analogy with OPV devices, it is assumed that I_g is directly related to the V_{OC} of the device, tuning the energy levels of the metal oxide and combining with different organic donors could result in significant improvements in the V_{OC} . Ferreria *et al.* investigated two ZnO deposition methods, a sol–gel derived ZnO layer and the formation of ZnO nanoparticles synthesised in methanol.²³

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In a simple bilayer device with the polymeric donor poly-(3-hexylthiophene) (P3HT), the V_{OC} was increased from 0.4 V to 0.6 V simply by replacing the ZnO sol-gel layer with ZnO nanoparticles. This was attributed to the increase in ZnO band gap resulting in a larger I_g . The substitution of polymers in HOPVs with evaporated organic small molecule semiconductors is an area that has received very little attention.^{24,25} One particular benefit is that it allows the controlled growth of very thin layers of the organic material, allowing the interface properties to be probed in a much more systematic way in order to explore the impact of the inorganic/organic junction on device performance. There have been a limited number of studies investigating TMO/organic small molecule interfaces with reported HOPV performances considerably lower than that of TMO/polymer cells.¹⁶ For example, in a recent study by Izaki *et al.* a hybrid phthalocyanine/ZnO buffer/n-type ZnO HOPV device resulted in a poor V_{OC} of 0.31 V and a power conversion efficiency (PCE) of just $1.6 \times 10^{-3}\%$.²⁶

In this paper, we show how the combination of a sol-gel processed ZnO layer with the small molecule organic semiconductor, boron subphthalocyanine chloride (SubPc), results in planar bilayer HOPV cells demonstrating very high open-circuit voltages. X-ray photoelectron spectroscopy (XPS) and Kelvin Probe (KP) measurements of the ZnO/SubPc interface show that the ZnO preparation conditions have a significant impact on the composition of the layers and the electronic properties of the interface, most notably the work function and interface gap energy, and careful optimisation leads to a high V_{OC} of 1.18 V and a respectable PCE of 0.47%, values much higher than those previously reported for similar device architectures.

2. Experimental details

ZnO thin films were fabricated on either pre-patterned ITO coated glass substrates (Thin Film Devices, 145 nm ITO thickness) or quartz substrates after a four-stage cleaning process and exposure to UV/ozone. A thin film of ZnO (~ 45 nm) was spin coated from a 0.25 M precursor solution containing acetone (VWR, 99.9%), zinc acetate (Aldrich, 99.99%) and 2-amino ethanol (Aldrich, 99.5%) which were used as the solvent, solute and chelating agent respectively. This solution was stirred for 1 hour prior to spin coating. The films were treated at two different annealing temperatures, 120 °C ($ZnO_{120^\circ C}$) and 160 °C ($ZnO_{160^\circ C}$), for 1 hour in air to allow conversion to ZnO. Atomic force microscopy (AFM) images were obtained using an Asylum Research MFP-3D (Santa Barbara, USA) in AC mode. The MFP-3D was fitted with an ORCA integrated tip-holder and current preamplifier (20 nA) for conductive atomic force microscopy (C-AFM) measurements. Both the topography and current distribution images were obtained simultaneously using Au/Cr coated cantilevers (Olympus TR400PB, tip radius < 40 nm, spring constant 0.06 N m^{-1}). To accurately determine the optical band gap using the method for non-crystalline semiconductors,^{27,28} thin films deposited onto a quartz substrate were

analysed by UV/vis electronic absorption spectroscopy using a Perkin Elmer Lambda 25 spectrophotometer.

Further analysis of the ITO/ZnO films was performed using XPS. The measurements were taken *ex situ* after loading into an ultra-high vacuum system with a base pressure of $\sim 2 \times 10^{-11}$ mbar. XPS measurements were recorded using a monochromated X-ray Al K_{α} source (Omicron XM 1000, $h\nu = 1486.6$ eV) and detected using an Omicron Sphera electron analyser at a take-off angle of 90°. A pass energy of 10 eV was employed for both core levels and VB (resolution = 0.47 eV). All spectral features were referenced to the C 1s peak (284.6 eV) and fitted using Lorentzian asymmetric lineshapes and Gaussian-Lorentzian lineshapes for zinc and oxygen respectively, both using a Shirley background.²⁹ KP measurements were used to determine the surface work function under a nitrogen atmosphere and referenced against freshly cleaved HOPG.

For device fabrication, SubPc (Lumtec 99%, 15 nm) and molybdenum oxide (MoO_x Aldrich 99.99%, 15 nm) were vapour deposited onto the prepared ZnO films, followed by an aluminium (Al) top electrode through a shadow mask to give an active area of 0.16 cm^2 using a Kurt J. Lesker Spectros system. All devices were tested under a nitrogen atmosphere in a sealed sample holder. Current density-voltage (J - V) measurements were recorded using a Keithley 2400 sourcemeter with AM1.5G solar irradiation simulated with a Newport Oriel solar simulator at an intensity of 100 mW cm^{-2} . The light intensity was calibrated with a Fraunhofer calibrated silicon photodiode (PV Measurements Inc.) with a KG-5 filter. EQE measurements were obtained using light from a Sciencetech Xe arc lamp solar simulator and a computer controlled PTI monochromator. The mechanically chopped, monochromatic light intensity was calibrated with a Si photodiode (818UV, Newport) as a reference cell. The current measurement was performed with a current-voltage amplifier (Femto DHPCA-100) and lock-in amplifier (Stanford Research Systems SR 830 DSP).

3. Results

C-AFM was used to study the effect the processing temperature has on the surface conductivity of the ZnO thin films. Fig. 1 shows simultaneously obtained topography images [a-b], current distribution maps [c-d] and histograms showing the corresponding current distributions [e-d] for $ZnO_{120^\circ C}$ and $ZnO_{160^\circ C}$. The $ZnO_{120^\circ C}$ film has a surface roughness of 0.90 nm, whereas $ZnO_{160^\circ C}$ has a slightly higher surface roughness of 1.95 nm. The current distribution maps were acquired whilst applying a 6 V bias, indicating a distinct difference in the surface currents obtained by varying film preparation conditions. The average current for $ZnO_{120^\circ C}$ was 63 pA, significantly smaller than the average current of 1.2 nA obtained for $ZnO_{160^\circ C}$ under the same conditions. The differences in surface conductivity are likely to be due to different phases of the ZnO layer which influences the currents expected and the interaction between the tip and the surface.³⁰



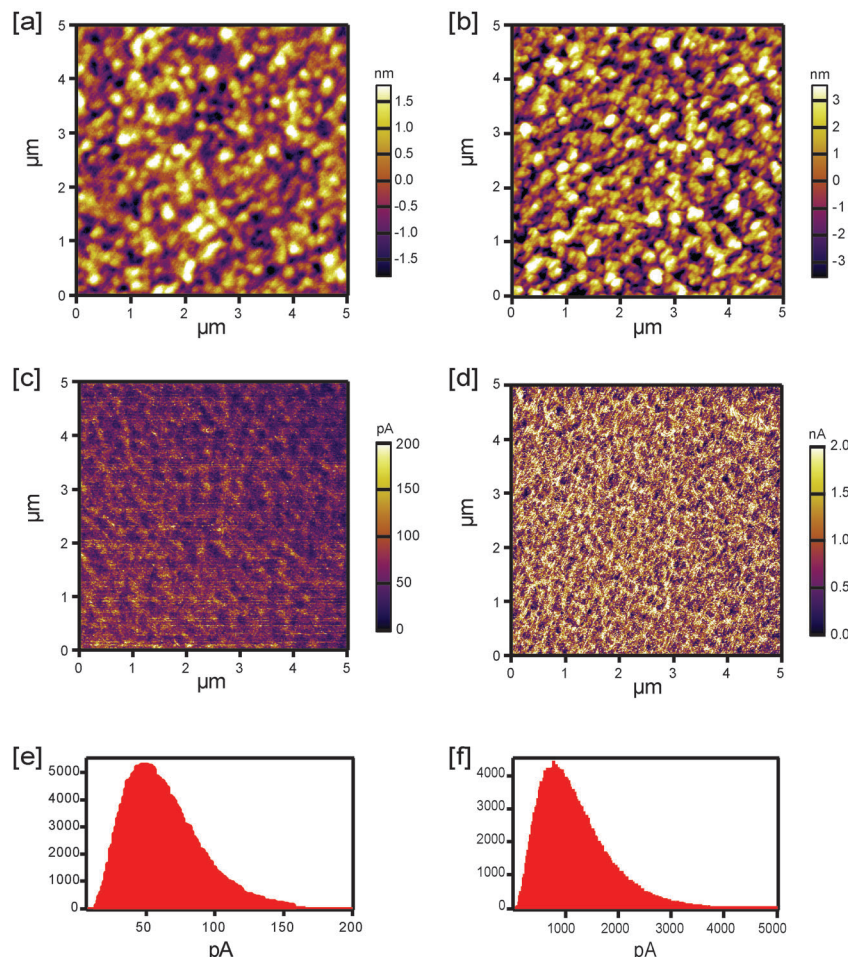


Fig. 1 Topographic AFM images and the corresponding current distribution maps at 6 V for [a, c] ZnO_{120°C} and [b, d] ZnO_{160°C}. Histograms showing the current distributions are also shown for [e] ZnO_{120°C} and [f] ZnO_{160°C}.

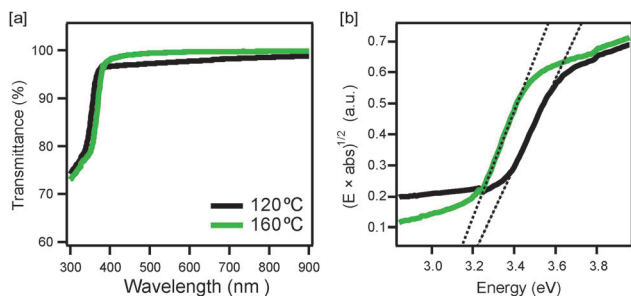


Fig. 2 [a] Transmittance data for a ZnO thin film spin-coated onto a quartz substrate against a quartz background for ZnO_{120°C} (black solid line) and ZnO_{160°C} (green solid line). [b] Determination of the band gap, E_g , by plotting $(E \times \text{abs})^{1/2}$ as a function of energy (eV) and determining the intercept with the energy axis (shown with the dotted lines).

The transmittance characteristics of the two ZnO films are summarised in Fig. 2. For both processing temperatures the films exhibit a high transmittance of $>95\%$ across the visible and near-infrared range (400–900 nm). The band gaps were calculated from the absorption profiles by the method developed for non-crystalline semiconductors,^{27,28} with $\alpha \propto \frac{1}{E} \cdot (E - E_g)^2$, giving a correlation

between the energy of an incoming photon, E and absorbance, α . The band gap, E_g , is then estimated from the intercept with the energy axis in a plot of E (eV) versus $(E \times \alpha)^{1/2}$, (Fig. 2[b]) giving band gaps of 3.26 eV and 3.15 eV, for ZnO_{120°C} and ZnO_{160°C} respectively. These values are consistent with the optical band gaps previously reported for ZnO thin films and show only slight variation at the two different processing temperatures.³¹

Table 1 A summary of the binding energies (eV), FWHM and compositions (%) for the Zn 2p and O 1s contributions shown in Fig. 1. Zn : O ratios are calculated using the Schofield relative sensitivity factors which are built in to CasaXPS, and an analyser transmission function calculated from poly Ag, Cu and Au foils

	eV	120 °C FWHM	%	eV	160 °C FWHM	%
Zn 2p _{3/2}	1020.80	1.541	28.59	1020.79	1.532	28.98
Zn 2p _{1/2}	1043.99	1.599	27.86	1043.89	1.584	29.25
O 1s _A	529.38	1.086	13.92	529.42	1.158	18.75
O 1s _B	530.77	1.853	29.62	530.88	1.794	23.02
Zn 2p _{3/2} : O 1s _A			1 : 0.49			1 : 0.64
Zn 2p _{3/2} : O 1s _B			1 : 1.42			1 : 0.96



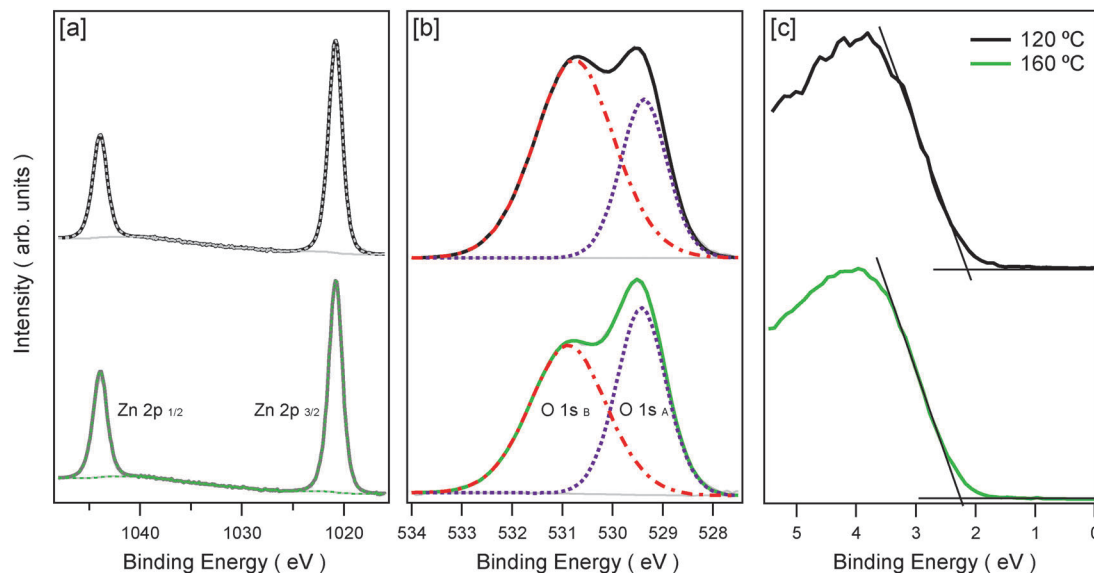


Fig. 3 XPS spectra of [a] Zn 2p, [b] O 1s and [c] the valence band (VB) onset for ZnO_{120°C} (black solid line) and ZnO_{160°C} (green solid line). The Zn region contains two peaks, Zn 2p_{3/2} and Zn 2p_{1/2}, in a 2 : 1 ratio owing to spin–orbit splitting. For O 1s, two components are present, O 1s_A (bound ZnO in a wurtzite lattice) and O 1s_B (contaminants present). The VB onset is calculated by the intercept with the binding energy axis.

To gain insight into the influence of processing temperature on ZnO composition, the films were characterised using XPS. Full spectra, including survey scans, are shown in the SI and the data is summarised in Table 1. Zn : O ratios are calculated using the Schofield relative sensitivity factors, which are built into CasaXPS, and an analyser transmission function calculated from polycrystalline Ag, Cu and Au foils. In Fig. 3[a], the Zn 2p peaks are shown for ZnO_{120°C} and ZnO_{160°C}, with two peaks observed, 2p_{3/2} (1020.8 eV) and 2p_{1/2} (1043.9 eV) in a 2 : 1 ratio due to spin–orbit splitting. Fig. 3[b], shows the comparative study of the core O 1s region, which comprises two unique components, a wurtzite lattice component with zinc coordinated to oxygen (O 1s_A, 529.4 eV), and a broad O 1s feature (O 1s_B, 530.8 eV) which can be attributed to contaminants. The full width at half-maximum (FWHM) of the two components differs, being 1.9 eV and 1.85 eV for O 1s_A and O 1s_B respectively, due to the difference in bonding environment, with a narrow peak as a result of coordination to the Zn atom. The contaminants present in O 1s_B can be firstly attributed to surface adsorbates which are a significant feature due to the surface sensitivity of XPS, but also to materials present in the sol–gel process; COH from the ethanolamine stabiliser and COO[−] which can be identified as the oxygen present in the zinc acetate raw material. It is a combination of materials adsorbed on the surface and starting materials trapped in the film that result in the larger FWHM. When comparing the ratio of Zn : O 1s_B at the two processing temperatures, there is a significant reduction in the contaminants due to the removal of the raw materials, resulting in a decrease in the ratio from 1 : 1.41 (ZnO_{120°C}) to 1 : 0.96 (ZnO_{160°C}).

The impact of defects in terms of the effect on carrier concentration and work function is still widely debated. In a recent paper by Greiner *et al.* it was reported that a change in

cationic oxidation state can result in a significant change in the work function of the TMO layer.³² This in turn could have an effect on the capability of the metal oxide to work as an electron acceptor due to the impact on the level of the CB and VB with respect to the vacuum level V_L , and in turn the organic donor material. By increasing the processing temperature by 40 °C, there is a change in the stoichiometry of the ZnO films with a Zn 2p_{3/2} : O 1s_A ratio of 1 : 0.49 for ZnO_{120°C} to 1 : 0.64 for ZnO_{160°C}. This suggests that the increase in temperature leads to an increase in the conversion to zinc oxide, which may alter the work function of these layers.

KP measurements were carried out to determine the work function of the two ZnO films. There is a significant difference in the work function of the layers, from 3.2 eV to 3.8 eV for ZnO_{120°C} and ZnO_{160°C} respectively. The VB edge XPS spectra for the two ZnO films are shown in Fig. 3[c] and provide further understanding of the electronic properties. The position of the surface Fermi level (E_{FS}) was determined by extrapolating the leading edge of the VB photoemission to the intercept with the background level. The E_{FS} for ZnO_{120°C} is 2.20 eV above the VB, giving a VB position of 5.40 eV below the V_L . In the case of ZnO_{160°C}, which has a similar E_{FS} of 2.25 eV, the film has a much deeper VB position of 6.05 eV below the V_L owing to the larger measured work function. These results are summarised in Fig. 4, with the positions of the CB estimated from the optical band gap (Fig. 1).

By sequentially depositing thin layers of the SubPc onto the ZnO surface further information can be gained about the electronic properties of the donor/acceptor interface. It is key to note here that unlike the small interfacial dipoles formed at an organic–organic interface, large V_L shifts would be expected for an inorganic–organic interface. Therefore, measurements indicating the energy level offsets in this region are essential for



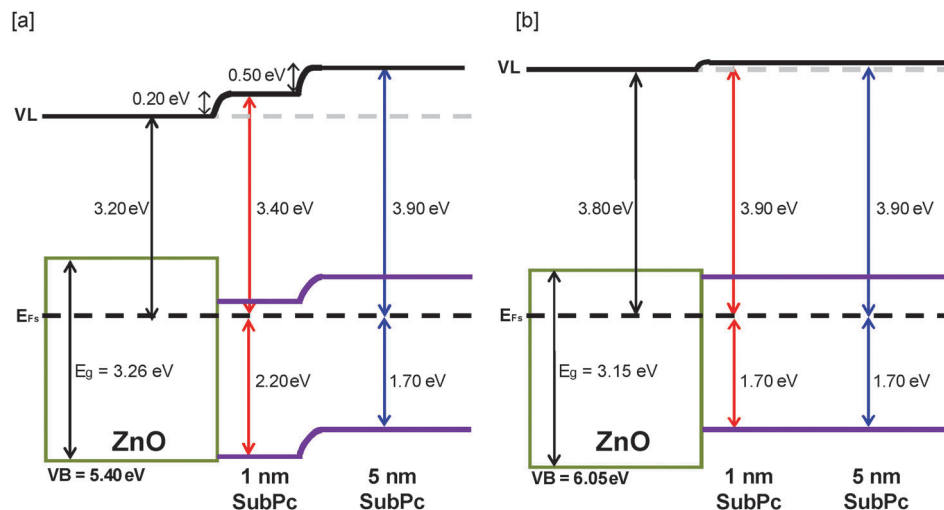


Fig. 4 Energy level diagrams for [a] a $\text{ZnO}_{120^\circ\text{C}}$ /SubPc and [b] a $\text{ZnO}_{160^\circ\text{C}}$ /SubPc bilayer after deposition of 1 and 5 nm of SubPc. The positions of the surface Fermi level (E_{FS}) and both the valence and conduction bands of the ZnO layers were determined by KP, XPS and UV-vis respectively.

understanding device parameters.^{33,34} Fig. 4 indicates the change in work function with subsequent growth of SubPc. For $\text{ZnO}_{120^\circ\text{C}}$ the work function is increased from 3.2 eV to 3.4 eV with the addition of 1 nm SubPc, resulting in a vacuum level shift of 0.20 eV. The work function increases further to 3.90 eV for a 5 nm SubPc layer. With deposition on $\text{ZnO}_{160^\circ\text{C}}$ there is only a subtle change in work function from 3.80 eV to 3.90 eV, and a small resultant vacuum level shift, for both the 1 and 5 nm thicknesses of the SubPc. This work function saturates past 5 nm of SubPc, and remains constant at 15 nm for both the ZnO films.

The position of the HOMO level of SubPc is included in Fig. 4, which is calculated by assuming an ionisation potential (IP) for SubPc of 5.60 eV.^{35,36} For organic/organic heterojunctions the I_g of the donor/acceptor interface is known to directly influence V_{OC} . If the same principle is used here, the maximum obtainable V_{OC} can be estimated from the difference between the $\text{HOMO}_{\text{SubPc}}$ and E_{FS} . This estimation is made due to the

n-type nature of ZnO thin films and the presence of gap states that have been shown to lie close to the E_{FS} of the material and can extract electrons.³⁷ Band bending in the near interfacial region of the organic (<5 nm) would be expected to provide an additional driving force for photocurrent extraction, and hence a larger expected V_{OC} . Thus, the interfacial region is of more significance than the bulk (>5 nm) collection levels of the organic. Consequently, if the difference in HOMO onsets with a 1 nm SubPc layer is considered, the value decreases from 2.20 eV ($\text{ZnO}_{120^\circ\text{C}}$) to 1.70 eV ($\text{ZnO}_{160^\circ\text{C}}$), and a difference in V_{OC} would be expected.

Table 2 Averaged HOPV device characteristics for the hybrid devices: ITO/ $\text{ZnO}_{(120^\circ\text{C or } 160^\circ\text{C})}$ /SubPc (15 nm)/ MoO_x (15 nm)/Al. The standard deviation for each parameter is shown in brackets

Temp ($^\circ\text{C}$)	J_{SC} (mA cm^{-2})	V_{OC} (V)	FF	PCE (%)
$\text{ZnO}_{120^\circ\text{C}}$	1.63 (0.10)	1.18 (0.09)	0.25 (0.03)	0.47 (0.05)
$\text{ZnO}_{160^\circ\text{C}}$	1.66 (0.14)	0.82 (0.10)	0.29 (0.01)	0.39 (0.07)

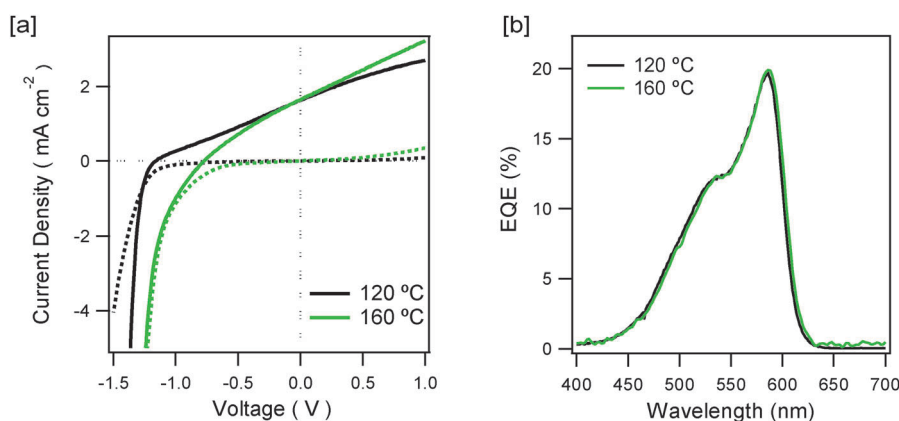


Fig. 5 [a] Averaged current density–voltage plots under illumination of 100 mW cm^{-1} for the ZnO/SubPc HOPV devices with $\text{ZnO}_{120^\circ\text{C}}$ (black solid line) and $\text{ZnO}_{160^\circ\text{C}}$ (green solid line). The corresponding dark current density–voltage plots are shown as dotted lines. [b] EQE of a representative pixel for $\text{ZnO}_{120^\circ\text{C}}$ (black solid line) and $\text{ZnO}_{160^\circ\text{C}}$ (green solid line).



To validate this hypothesis, bilayer HOPV cells were fabricated with the architecture: ITO/ZnO (45 nm)/SubPc (15 nm)/MoO_x (15 nm)/Al. Key device parameters are shown in Table 2 with the corresponding *J*–*V* plots in Fig. 5[a]. The thickness of the SubPc layer was kept constant at 15 nm as it is consistent with previously published exciton diffusion lengths for the material.^{38,39} As predicted there is a significant improvement in *V*_{OC} from 0.82 V for ZnO_{160°C} to 1.18 V for ZnO_{120°C}, demonstrating clearly the significance the increase in *I*_g has on the achievable *V*_{OC} for these hybrid devices. Another factor contributing to the difference in *V*_{OC} could be the suppression in dark current due to lower mobility of the films. However this affect is likely to be more of a secondary causation.

The voltage achieved for this cell is very high for a single junction cell and shows the potential of organic donors to be utilised with TMO acceptors for high performance. The enhanced *I*_g, along with the high IP SubPc donor results in higher *V*_{OC} values than obtained with polymeric alternatives such as P3HT, which typically yield values less than 0.7 V.²³ There is approximately a 1 eV difference between the predicted *I*_g and the measured *V*_{OC} of the device, which is not uncommon for excitonic solar cells due to the losses associated such as the exciton binding energy, recombination of charge transfer states and the diffusion of charge carriers to the electrodes.⁴⁰ Also owing to the nature of the ZnO film and the fact that there are likely to be gap states near to/around the *E*_{FS} it is difficult to pinpoint the exact energy at which charges will be extracted.

The thin ZnO electron accepting layer, owing to its wide optical band gap, has high transparency across the entire visible range, so does not contribute to the photocurrent during device operation. This is shown in Fig. 5[b] which shows the EQE of the two device architectures, showing only the SubPc film contributes to the current of the device. Despite only one current contributor, the optimised ZnO/SubPc hybrid devices gave a relatively high *J*_{SC} of >1.5 mA cm^{−2}, outperforming other TMO/small molecule hybrid devices where the best published value for *J*_{SC} currently stands at 0.015 mA cm^{−2}.²⁶ This indicates that ZnO_{120°C} and ZnO_{160°C} are both efficient at splitting excitons at the interface with SubPc. The main limitation of the devices is the low fill factors (FF) of 0.25 and 0.29 for ZnO_{120°C} and ZnO_{160°C} respectively, and this is likely to be due to a photoconductivity effect in the layer, with shunts being exposed when scanning. Despite a 6 V bias being applied during the C-AFM measurements there is a poor averaged surface current of 63 pA for ZnO_{120°C} which can be seen in Fig. 1[c]. The average current is greatly improved to 1.2 nA for ZnO_{160°C} (Fig. 1[d]) which in turn explains the improvement in FF to 0.29. This is likely to be due to removal of impurities and adsorbates on the surface at the higher annealing temperature (seen by XPS), improving the surface conductivity and resistance. Despite the low FF, the PCE of the devices increases from 0.39% (ZnO_{160°C}) to 0.47% (ZnO_{120°C}) merely by a 40 °C decrease in the ZnO processing temperature, with the improvement primarily attributed to the increase in *V*_{OC}. The voltage exceeds that of SubPc/C₆₀ devices, which are reported at approximately 1.05 V,³⁶ showing the potential of ZnO as a low

temperature, cheap scalable alternative to C₆₀ for use in bilayer HOPV cells.

4. Conclusions

We have demonstrated that ZnO films fabricated using the sol-gel process can be incorporated in bilayer HOPV devices with a small molecule organic donor layer. The effect of processing temperature on the characteristics of the ZnO layer was investigated using C-AFM, UV-Vis absorption, XPS and KP measurements and revealed an increase in the ratio of the ZnO 2p_{3/2}:O 1s_A as the processing temperature was decreased from 160 °C to 120 °C. This change in stoichiometric ratio resulted in a decrease in the work function of the layer, but an increase in the overall *I*_g. HOPV devices showed an increase in *V*_{OC} of 0.36 V, from 0.82 V to 1.18 V, a consequence of the increased *I*_g. The results demonstrate that ZnO can be used as an electron acceptor in small molecule hybrid planar bilayer cells achieving a very respectable PCE of 0.47%, two orders of magnitude larger than previously reported small molecule hybrid cells, and with a remarkably high *V*_{OC} of 1.18 V.

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